



PATENT

Atty. Dkt. No. AMAT/6394/PPC/ECP/RKK

1753  
Jew

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:  
Kovarsky

Serial No.: 10/074,569

Confirmation No.: 6592

Filed: February 11, 2002

For: Apparatus and Method for  
Removing Contaminants  
from Semiconductor  
Copper Electroplating BathsMAIL STOP AMENDMENT  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

§ Group Art Unit: 1753

§ Examiner: Arun S. Phasge

CERTIFICATE OF MAILING 37 CFR 1.8	
I hereby certify that this correspondence is being deposited on <u>9/16/04</u> , 2004 with the United States Postal Service as First Class Mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.	
<u>9/16/04</u>	<u>Kewin Z. Zeldis</u>
Date	Signature

## RESPONSE TO OFFICE ACTION DATED JUNE 16, 2004

In response to the Office Action dated June 16, 2004, having a shortened statutory period for response set to expire on September 16, 2004, please enter this response and reconsider the claims pending in the application for reasons discussed below. The Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/AMAT/6394/KMT, the fee of \$54.00 for three additional total claims, and for any other fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

**Amendments to the Specification** begin on page 2 of this paper. **Amendments to the Claims** are reflected in the listing of claims which begins on page 11 of this paper. **Amendments to the Drawings** begin on page 21 of this paper and include both attached replacement sheets and annotated sheets showing changes. **Remarks** begin on page 22 of this paper.